

JACOBSON HOLMAN PLLC
 400 SEVENTH STREET, N.W.
 WASHINGTON, D.C. 20004-2201

LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

ATTY. DOCKET NO.: P69995US0 GROUP ART UNIT: Not Yet Assigned
 SERIAL NO.: New Application FILING DATE: August 3, 2004
 APPLICANT(S): Yong Hae KIM, et al. TODAY'S DATE: August 3, 2004

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	INT'L CLASS	SUB- CLASS	FILING DATE (If Appropriate)
DG	AA	6,166,399	12/26/00	Zhang, et al.	H01L 29/04	6/19/99
	AB					

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION (YES) (NO)
DG	AC	2002-50766	2/15/02	JAPAN	H01L 29/786	X
	AD					

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

DG
 AE Isao Hasegawa, et al.; "A Novel Crystallization Method for Silicon Films with a Near-infrared Laser and Absorption Layer - Zone Melting for Films -"; TFT2-1; AM-LCD' 03; pp. 25-28.

EXAMINER

/David E. Graybill/

DATE CONSIDERED

01/04/2007

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).